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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Dwight Zuck and David Zuck

Assignee: Quantum Global Technologies, LLC

Title: System for Removing Contaminants from  
Semiconductor Process Equipment

Serial No.: 10/622,393 Filed: 07/18/2003

Examiner: Stinson, Frankie L. Group Art Unit: 1746

Atty. Doc. No.: Z-001-2C

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Mail Stop \_\_\_\_\_  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN RESPONSE TO FIRST OFFICE ACTION

Sir:

In response to the Office Action dated June 17, 2004, please amend the above-identified patent application as follows:

08/31/2004 HVUONG1 00000005 10622393

01 FC:2202 54.00 0P  
02 FC:2201 43.00 0P